



B  
afw

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q68480

Hidemitsu AOKI, et al.

Allowed: November 18, 2003

Appln. No.: 10/071,184

Group Art Unit: 2823

Confirmation No.: 2961

Examiner: Joannie A. Garcia

Filed: February 11, 2002

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

**SUBMISSION OF DRAWINGS**

**MAIL STOP ISSUE FEE**

**ATTN: OFFICIAL DRAFTSPERSON**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Submitted herewith please find 1 sheet of drawings in compliance with 37 C.F.R. § 1.84. The Examiner is respectfully requested to acknowledge receipt of this drawing.

The submitted drawing incorporate the proposed drawing changes approved in Paper No. 20031105 and are believed to obviate the informalities indicated on Form PTO-948 attached to Paper No. 0506.

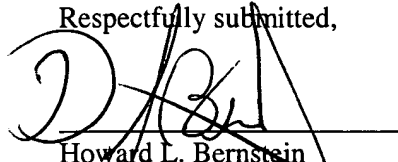
SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Respectfully submitted,

  
Howard L. Bernstein  
Registration No. 25,665

Date: May 26, 2004